

**METHOD, SYSTEM AND FACILITY FOR MONITORING RESOURCES
WITHIN A MANUFACTURING ENVIRONMENT**

ABSTRACT OF THE DISCLOSURE

A method, system and logic are described for monitoring resources within a manufacturing environment. A system for monitoring resources within a manufacturing facility includes a remote monitoring system coupled to one or more pieces of equipment within the manufacturing facility. The remote monitoring system may be communicatively coupled to a control center operable to display status information associated with using the one or more pieces of equipment.